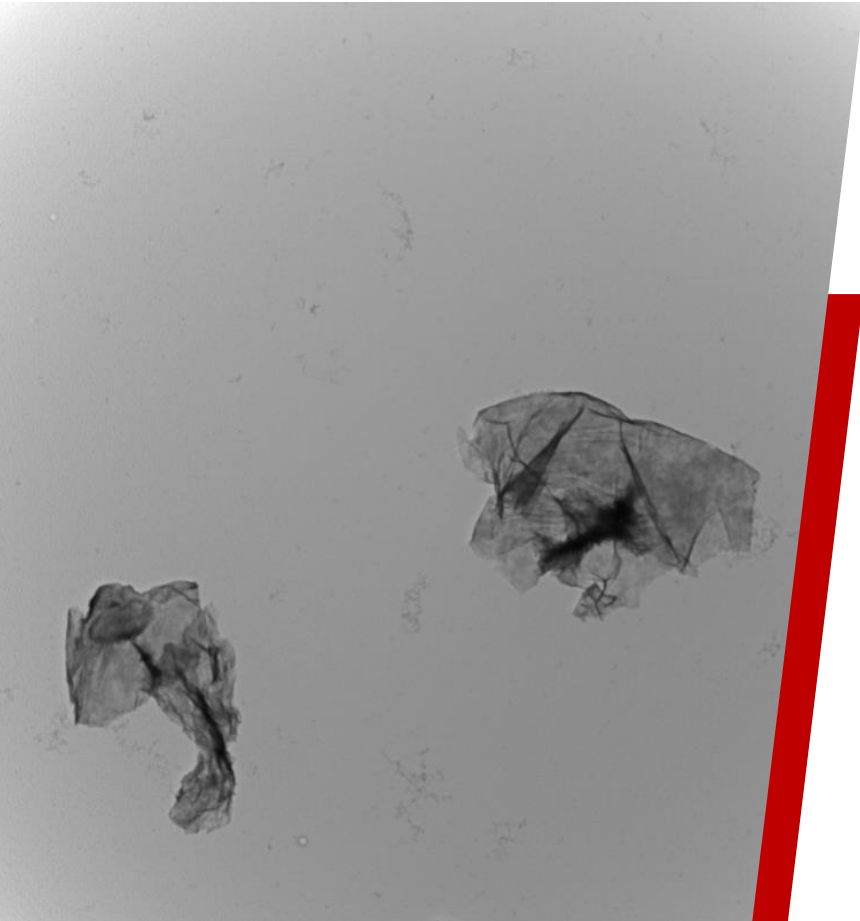




Challenges in the synthesis and characterization of 2D materials (Part 2)

Dr. Giacomo Reina

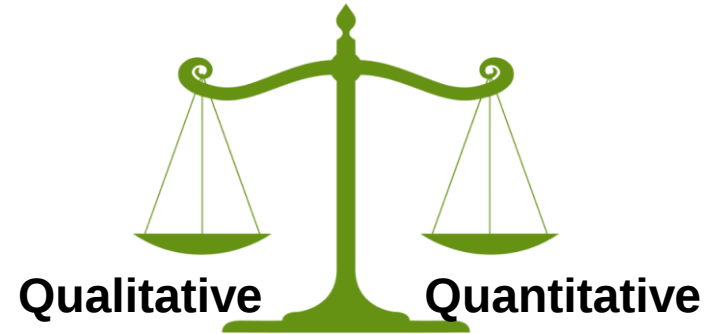
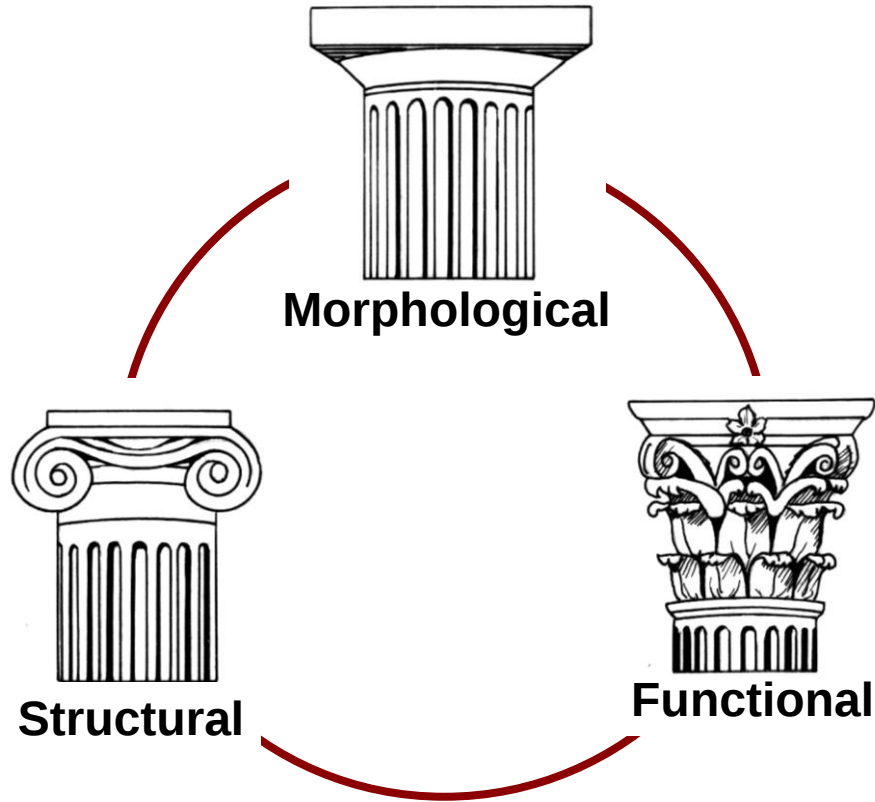
20.08.24 Visp

Outline

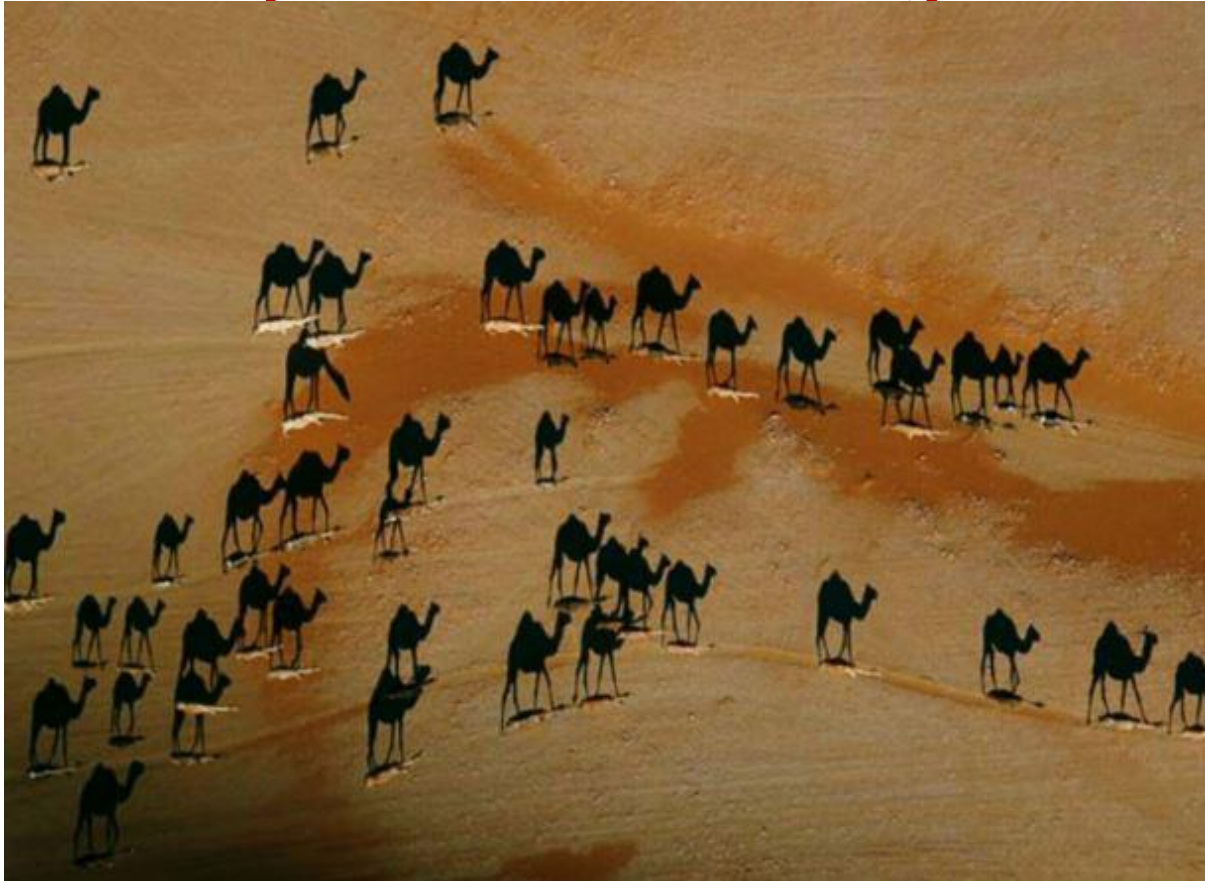


- 2D Nanomaterials: Timeline
- 2D Nanomaterials: Who are they?
- Synthetic Methods: Bottom-up
- Synthetic Methods: Top-Down
- Overview and Questions

The “pillars” of characterization



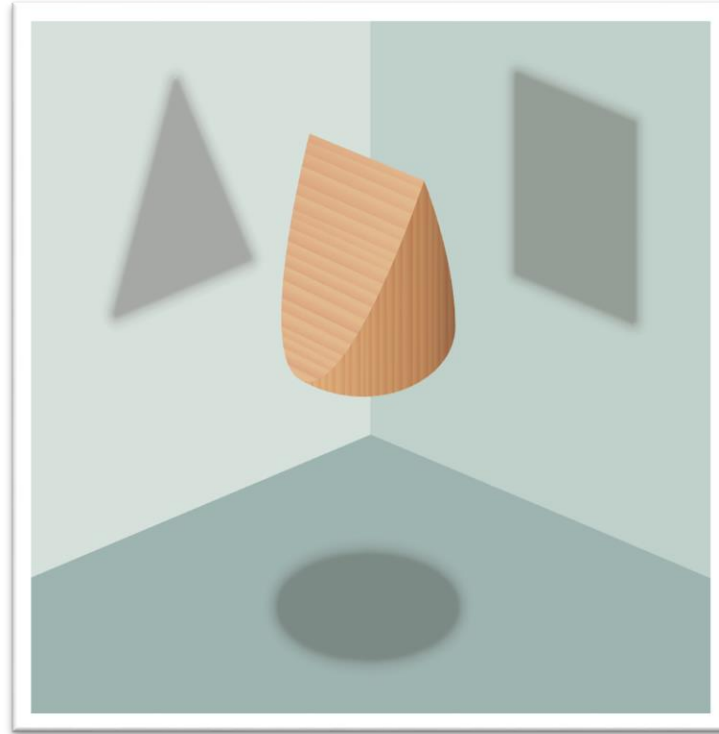
The viewpoint: bird-view vs frog-view



Micro characterization vs Bulk

George Steinmetz, National Geographic 2005

The combination of different methods is needed to understand the (nano)material completely



What can we measure to characterize NMs?



Interaction with EMF
(Spectroscopy)



Mass changes
(Gravimetric)

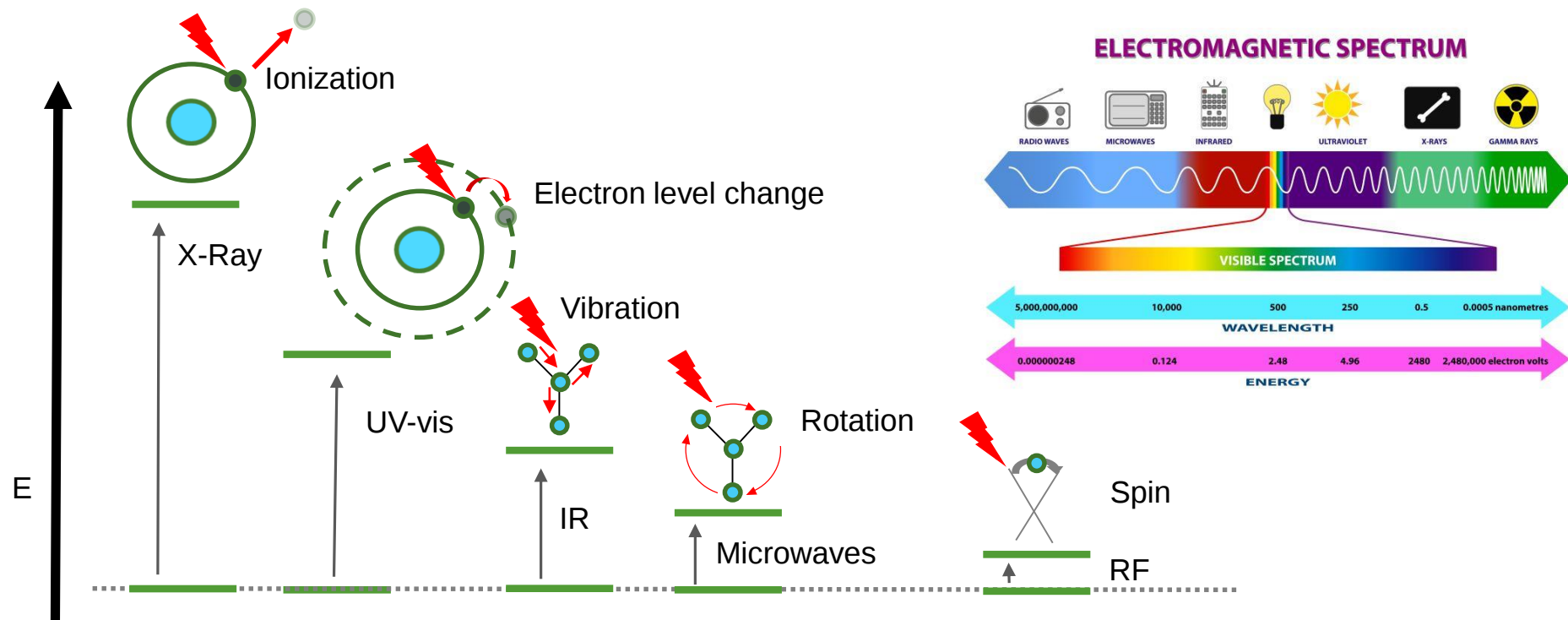


Physical interactions
(Scanning probes)

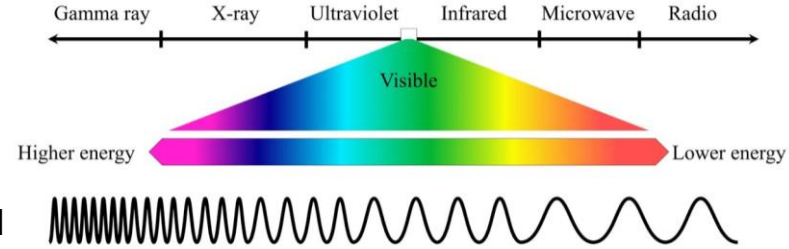
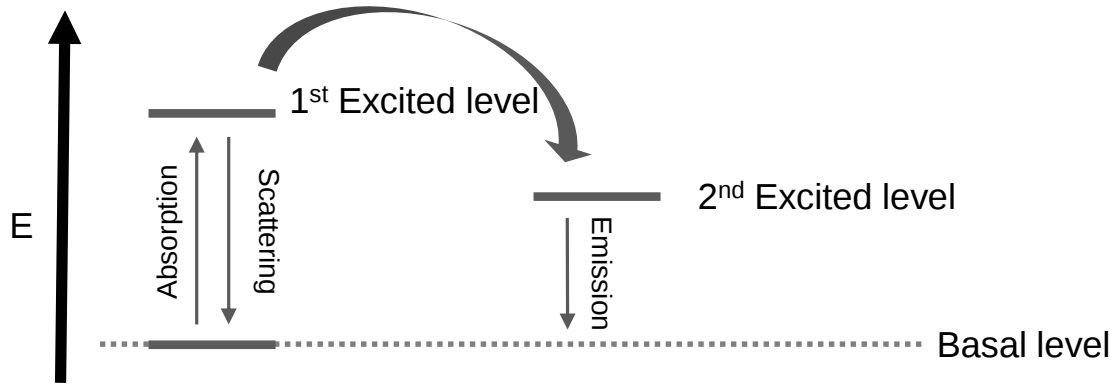
Interaction with electromagnetic field



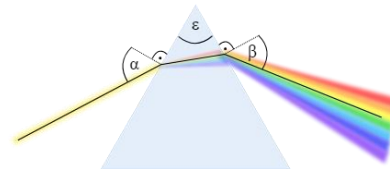
Aleksander Jabłoński



Interaction with electromagnetic field

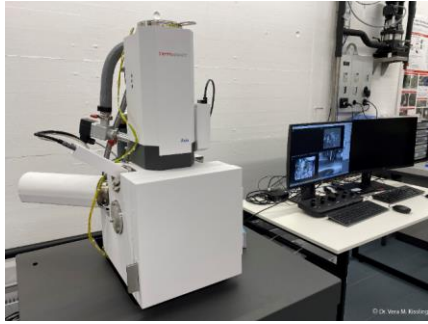


Absorbed energy > Emitted of energy

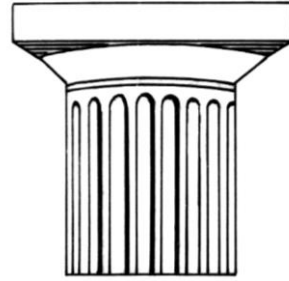


Diffraction

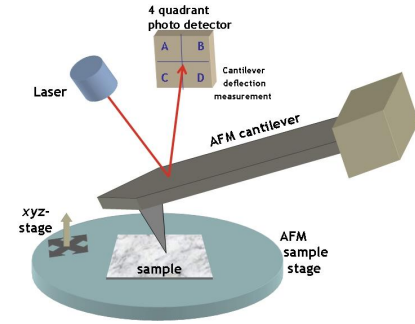
If we excite with green light where should we expect the emission?



SEM



Morphological

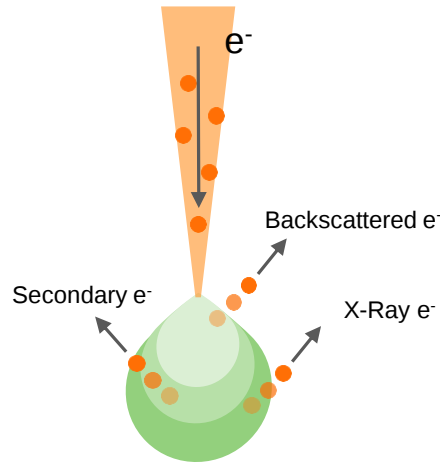
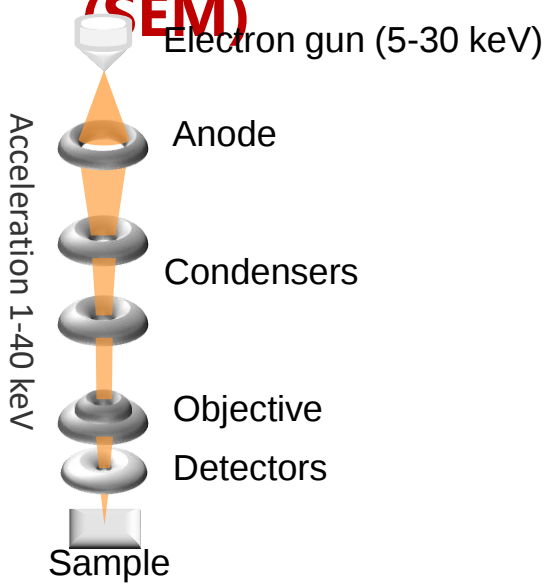


AFM

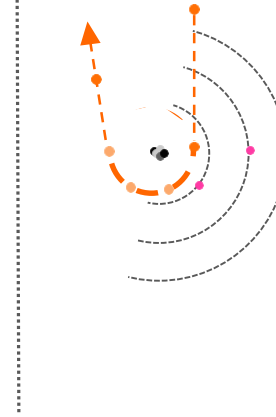


TEM

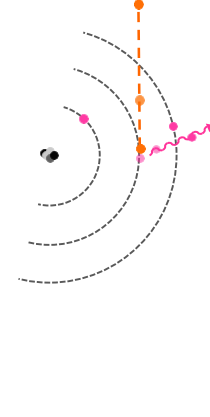
Morphology: Scanning Electron Microscopy (SEM)



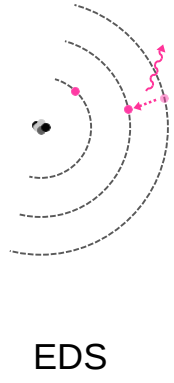
Backscattering



Secondary e^-

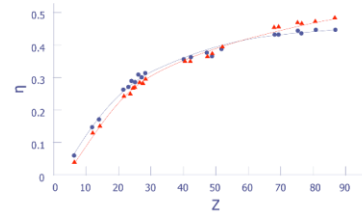


X-Ray



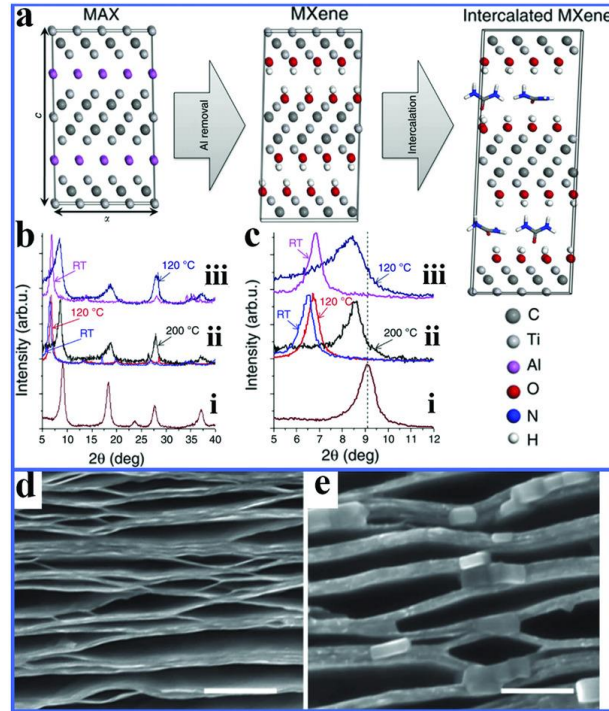
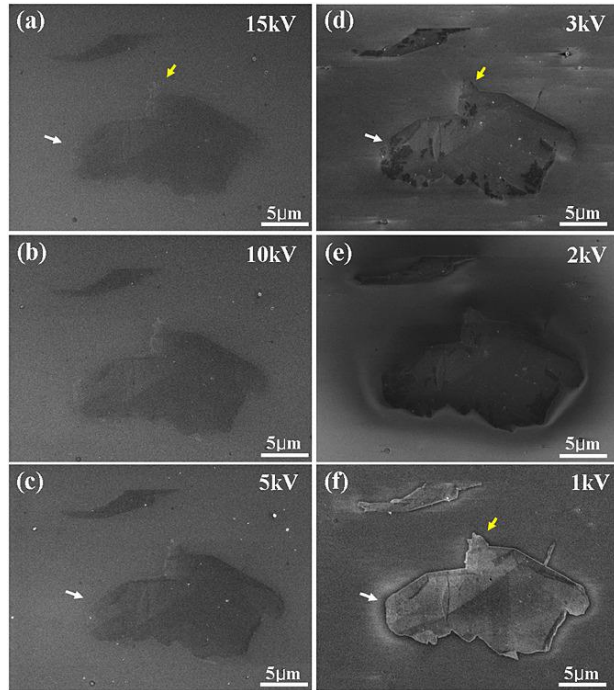
EDS

$$\eta = \frac{n_{BS}}{n_B}$$



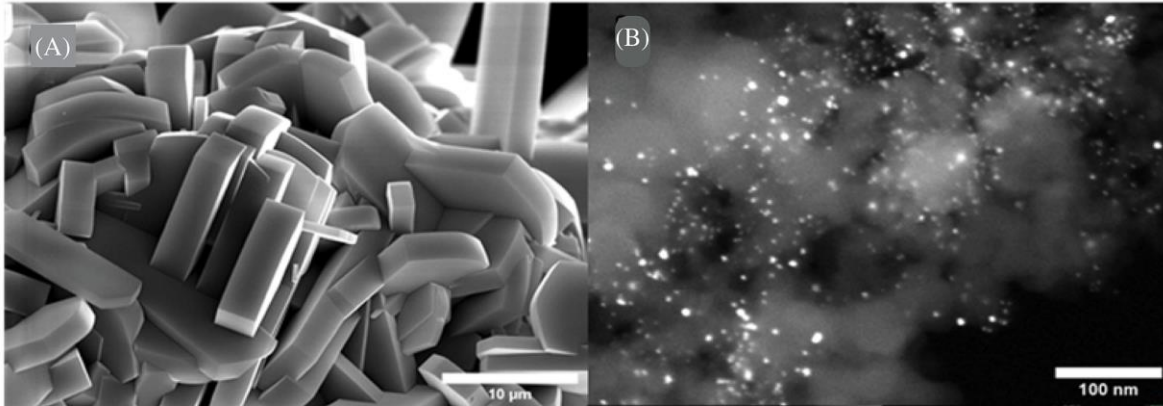
Can you tell which one is a scattering, absorption and emission process?

Morphology: Scanning Electron Microscopy (SEM)

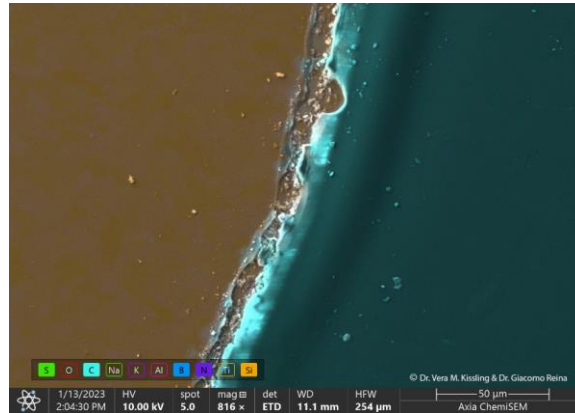
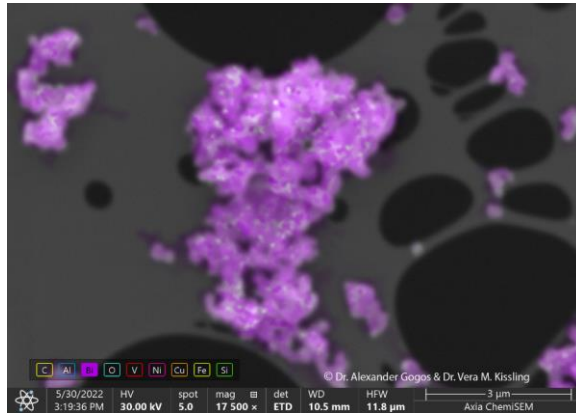


Morphology: Scanning Electron Microscopy (SEM)

ETH zürich



(A) secondary electron image of silicon aluminium oxide using an in-lens secondary electrons (SE) detector; (B) backscattered electron (BSE) image of palladium nanoparticles, the particles appear as the brighter spots against the Al_2O_3 support.



Bismuth nanoparticle agglomerates Nanoparticle-containing gel on glass

Davies, Thomas E., et al. *The Canadian Journal of Chemical Engineering* 2022

Morphology: Scanning Electron Microscopy (SEM)

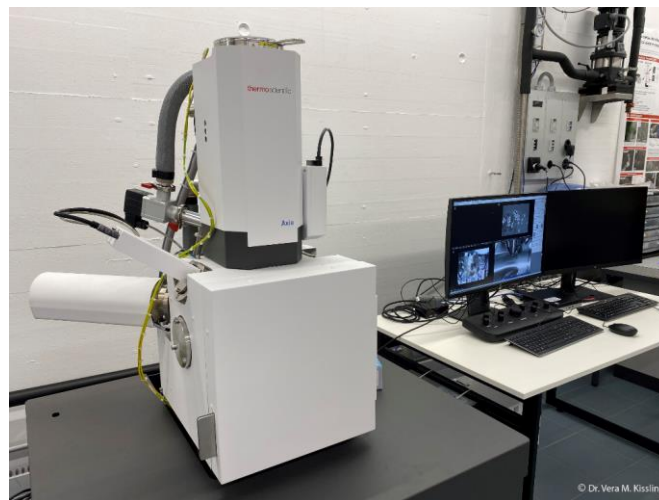


Considerations:

- SEM is a common technique for NMs surface morphology characterization
- The sample is normally dried on a support (no limit about thickness or size)
- NMs made conductive
- Resolution is between 2 and 20 nm

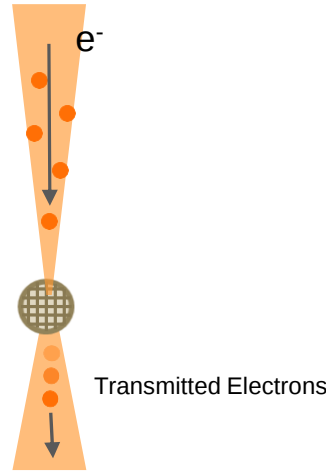
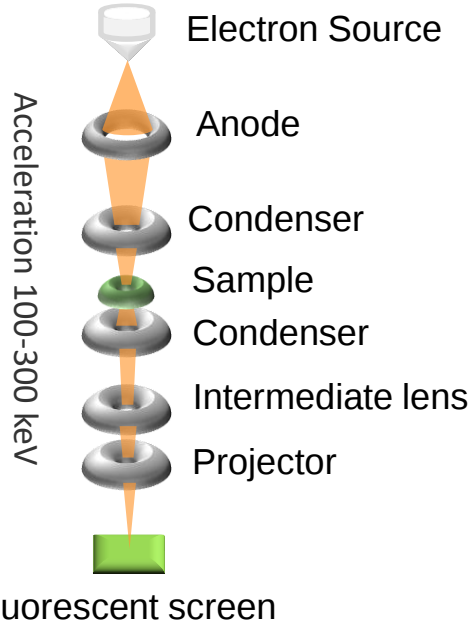
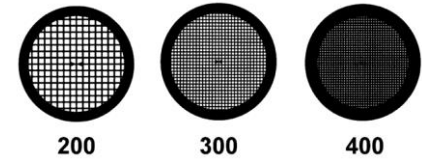
Applications:

Surface analysis, surface morphology, microanalysis

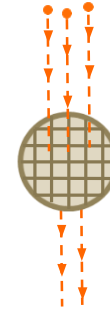


Do you know how to make NMs conductive?

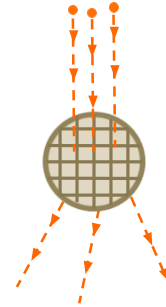
Morphology: Transmission Electron Microscopy (TEM)



Intensity



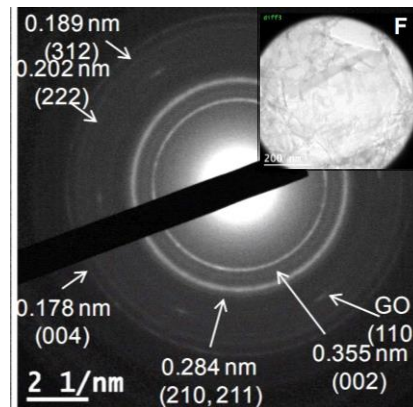
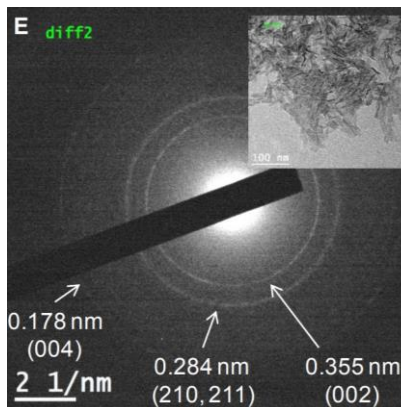
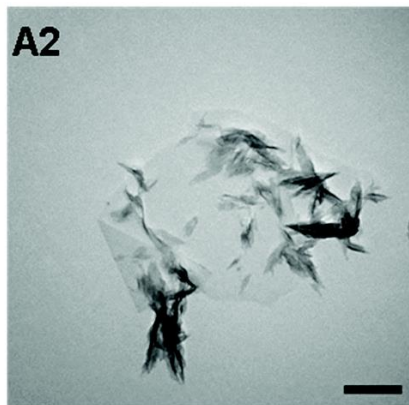
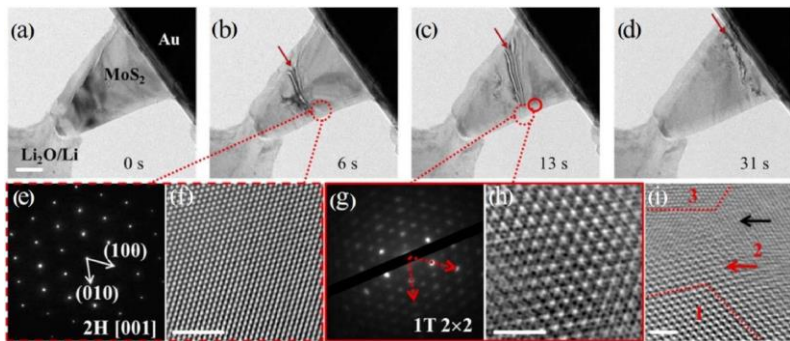
Diffraction



$$\lambda = 1.22 / E^{1/2}$$

TEM imaging a sample with 100 keV electrons is capable of a theoretical resolution of 0.004 nm.

Morphology: Transmission Electron Microscopy (TEM)



Morphology: Transmission Electron Microscopy (TEM)



Considerations:

- TEM is a consolidated technique for NMs characterization
- The must be thin (<200 nm) and is deposited onto a special grid
- The instrument is expensive
- The sample preparation require “experts”
- Resolution is between 0.15 and 0.2 nm

Applications:

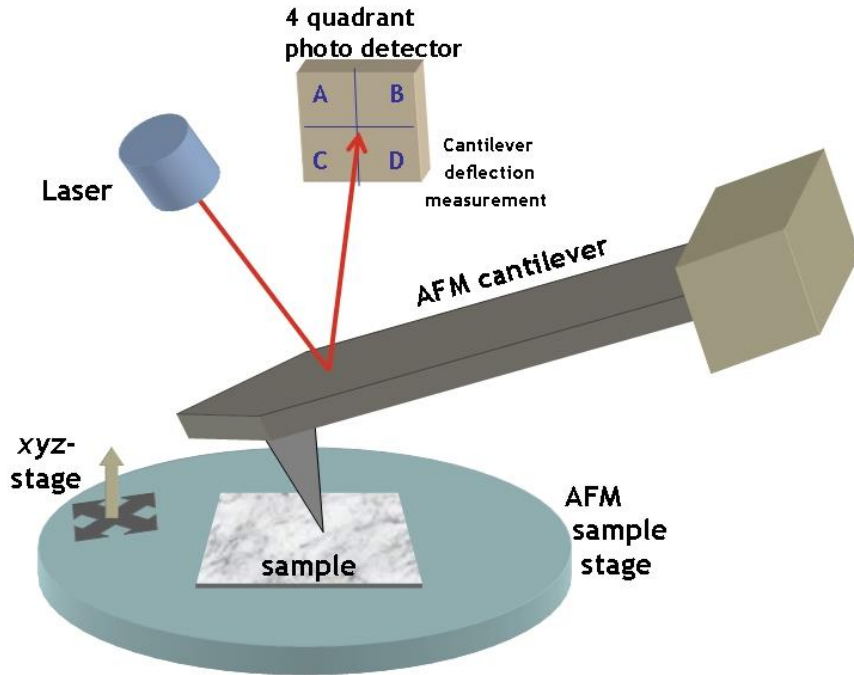
Surface morphology, microanalysis, size distribution



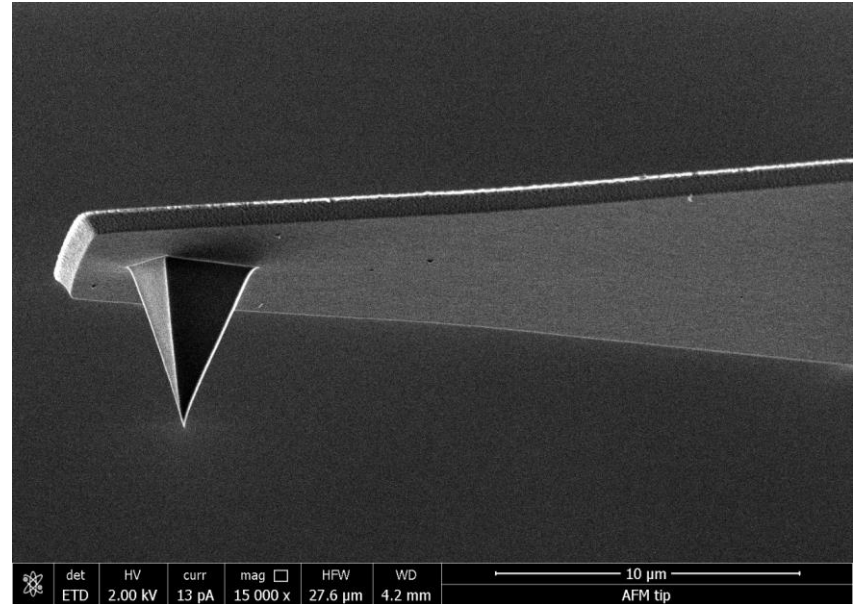
Morphology: Atomic Force Microscopy (AFM)



A very fine tip gropes the surface gradually. With the help of a LASER beam the movement becomes visible.



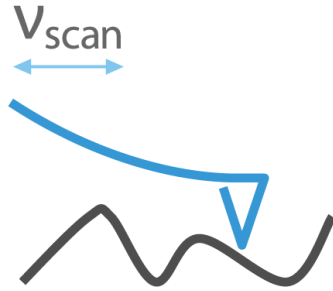
A cantilever scans the sample surface



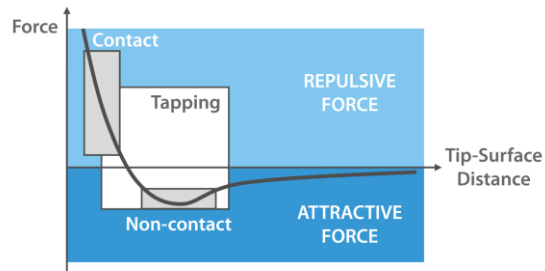
Morphology: Atomic Force Microscopy (AFM)



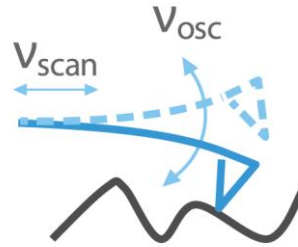
Contact Mode



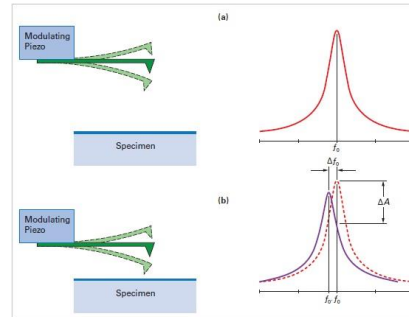
CONTACT MODE



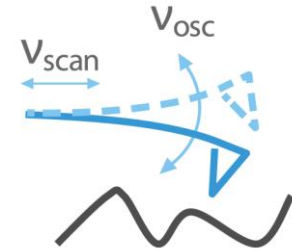
Tapping Mode



TAPPING MODE

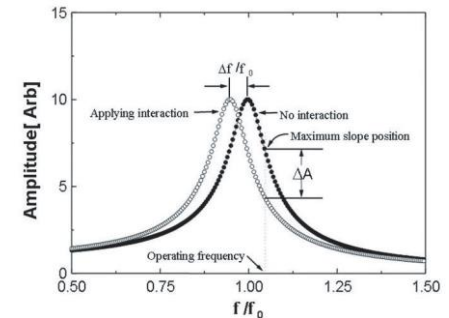


Non-Contact Mode

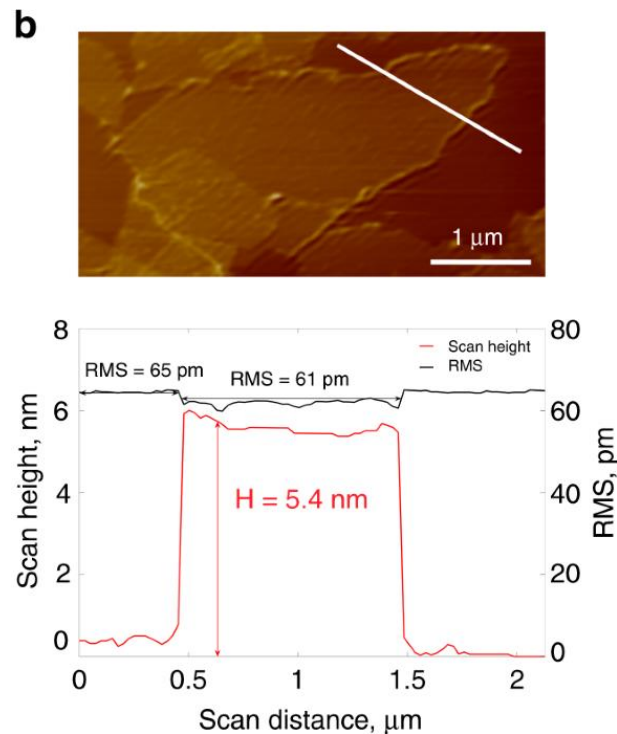
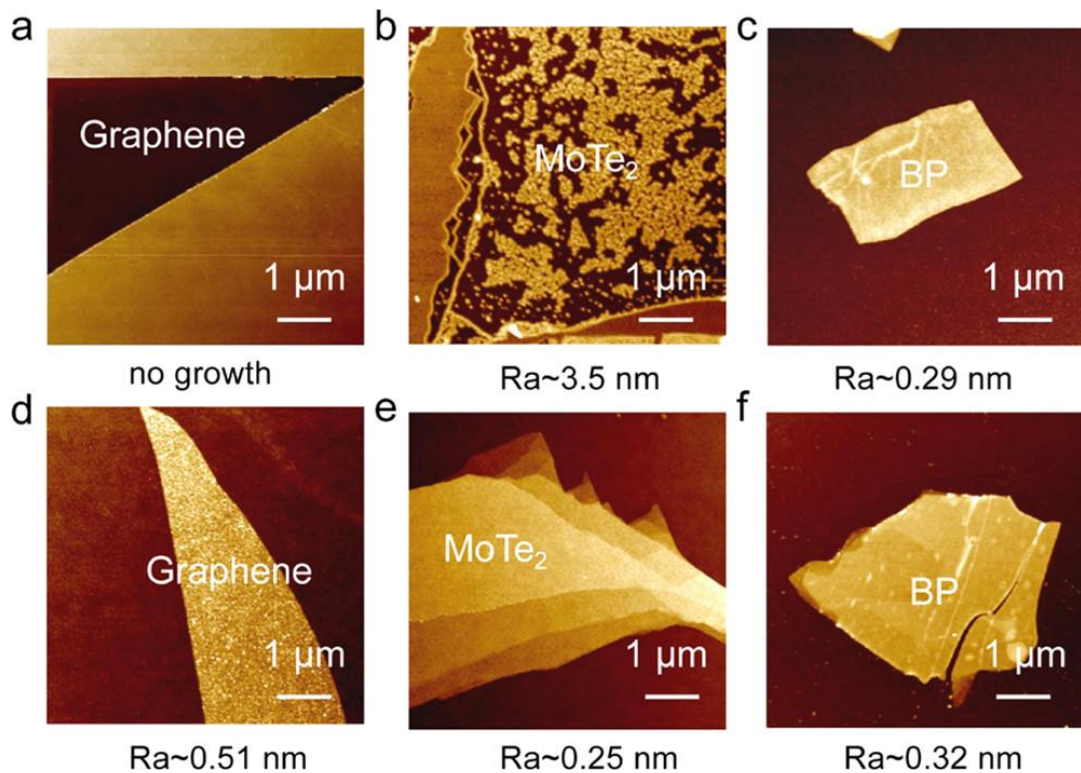


NON-CONTACT MODE

$$f_0 = \sqrt{\frac{k_0}{m}} \quad f_{\text{eff}} = \sqrt{\frac{k_{\text{eff}}}{m}}$$



Morphology: Atomic Force Microscopy (AFM)



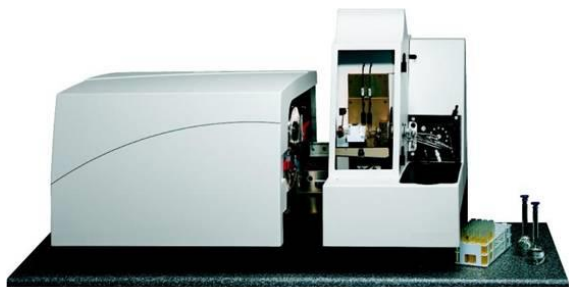
Morphology: Atomic Force Microscopy (AFM)



Considerations:

- AFM is physical technique to characterize the NMs morphology
- Depending of the NMs 3 techniques can be used
- AFM can be used at RT, atmospheric condition or in solution
- The analysis requires long time for acquisition
- Normally an “expert” is implied in the analysis

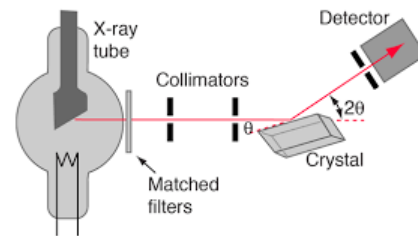




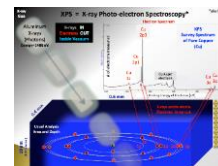
Mass spectrometry



Structural



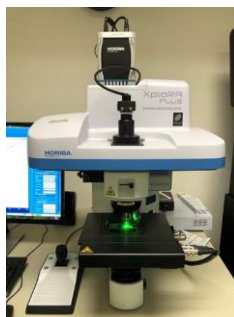
XRD



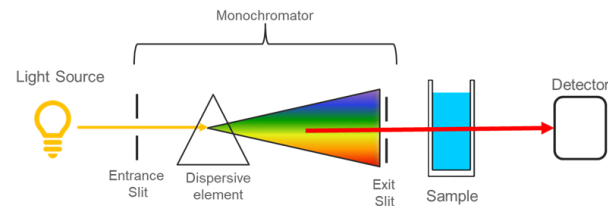
XPS



TGA



Raman



UV-vis spectrometry



Structural Characterizations: Thermogravimetric Analysis



The sample is weighed and placed in a pan.

The NMs are then placed in a controlled oven.

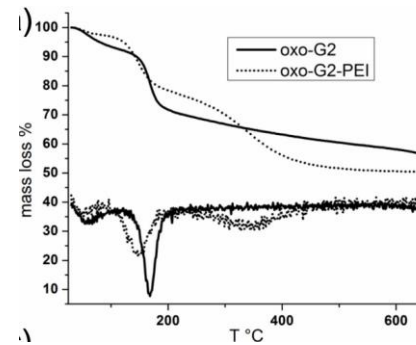
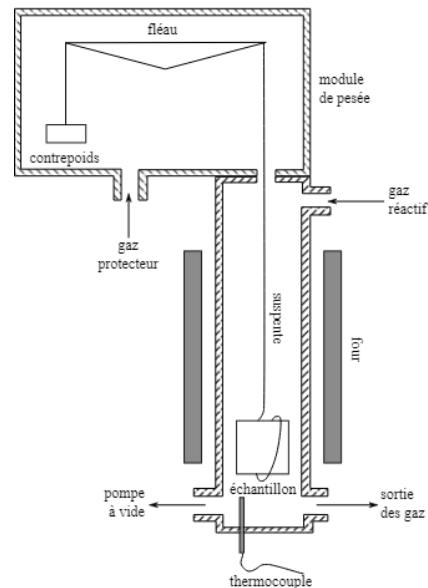
The oven is settled to a T ramp in a controlled inert or oxidizing atmosphere

During the process, the weight of the sample is constantly measured

During the measurement the thermogram of the sample is measured

TGA is used also to quantify the functionalization.

Differential analysis (DTG) is used to measure the T of decomposition



Structural Characterizations: X-Ray Diffraction analysis (XRD)



Atoms can scatter X-ray sources

A regular array of scatters produces a regular array of spherical waves

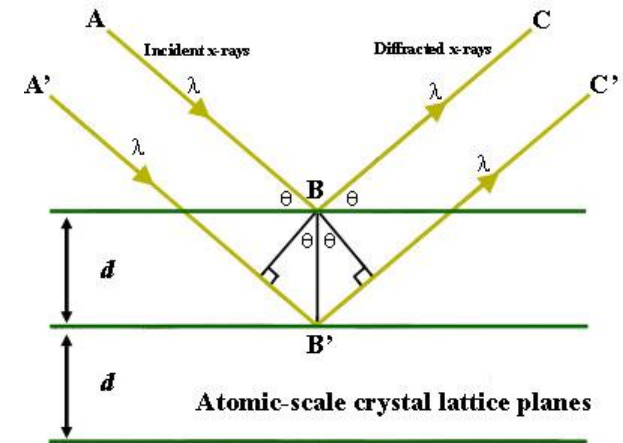
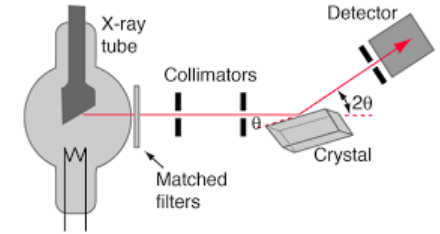
The scatter is constructive only in few specific directions according to the Bragg's law

$$2d\sin(\theta) = n\lambda$$

The average lattice structure size can also be determined by the Scheer law:

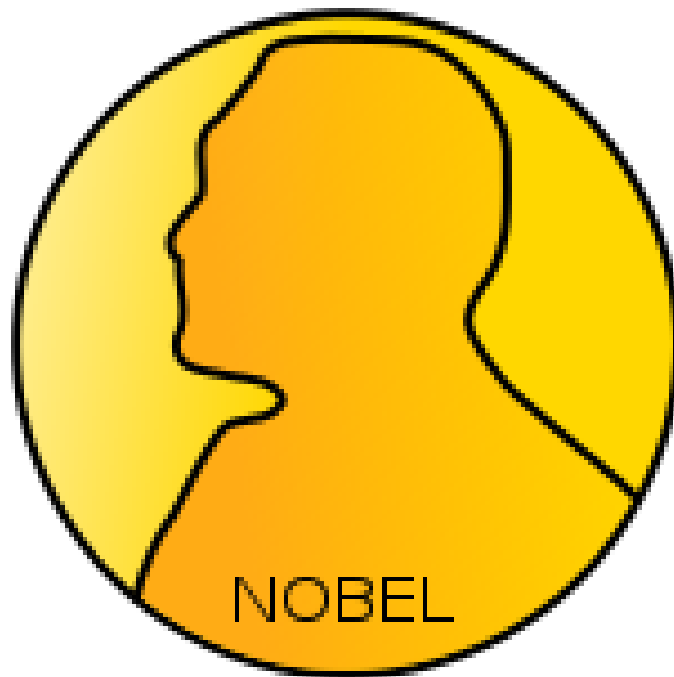
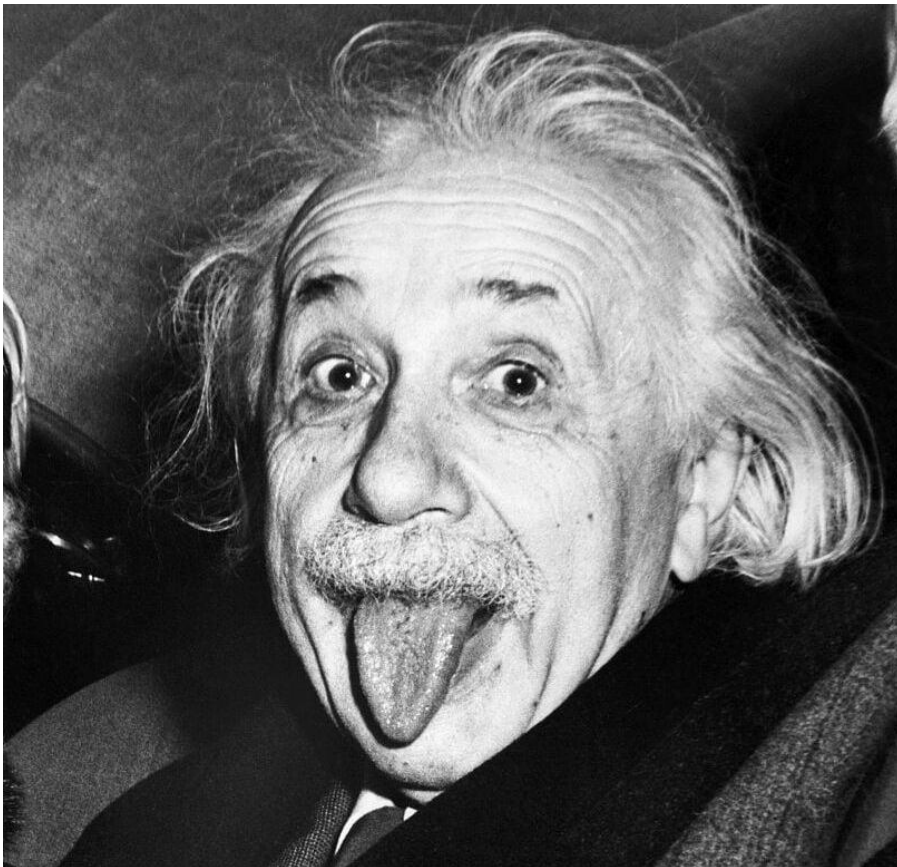
The spectra is then compared with literature or with a database

Used to analyze crystalline samples



Do you think that XRD is a bulk or a micro characterization?

Nobel Quiz



1921

Structural Characterizations: X-Ray Photoelectron Spectroscopy



XPS is based on photoelectric effect

The sample in a thin film is placed at high vacuum

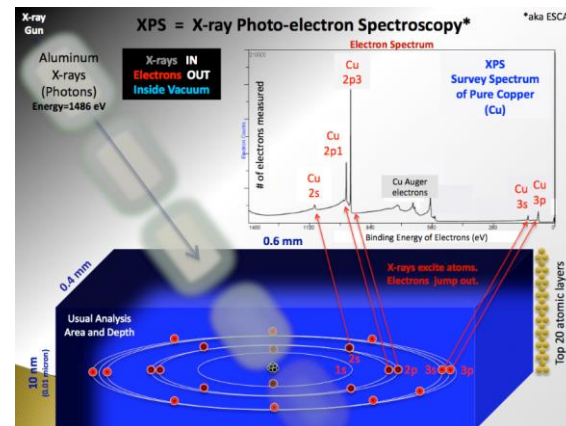
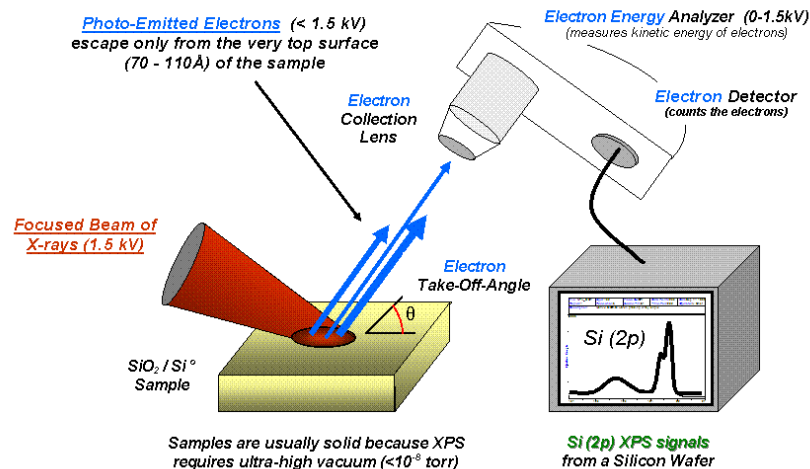
Monochromatic X-Ray source is used as excitation source

Electron are then collected and their binding energy is measured:

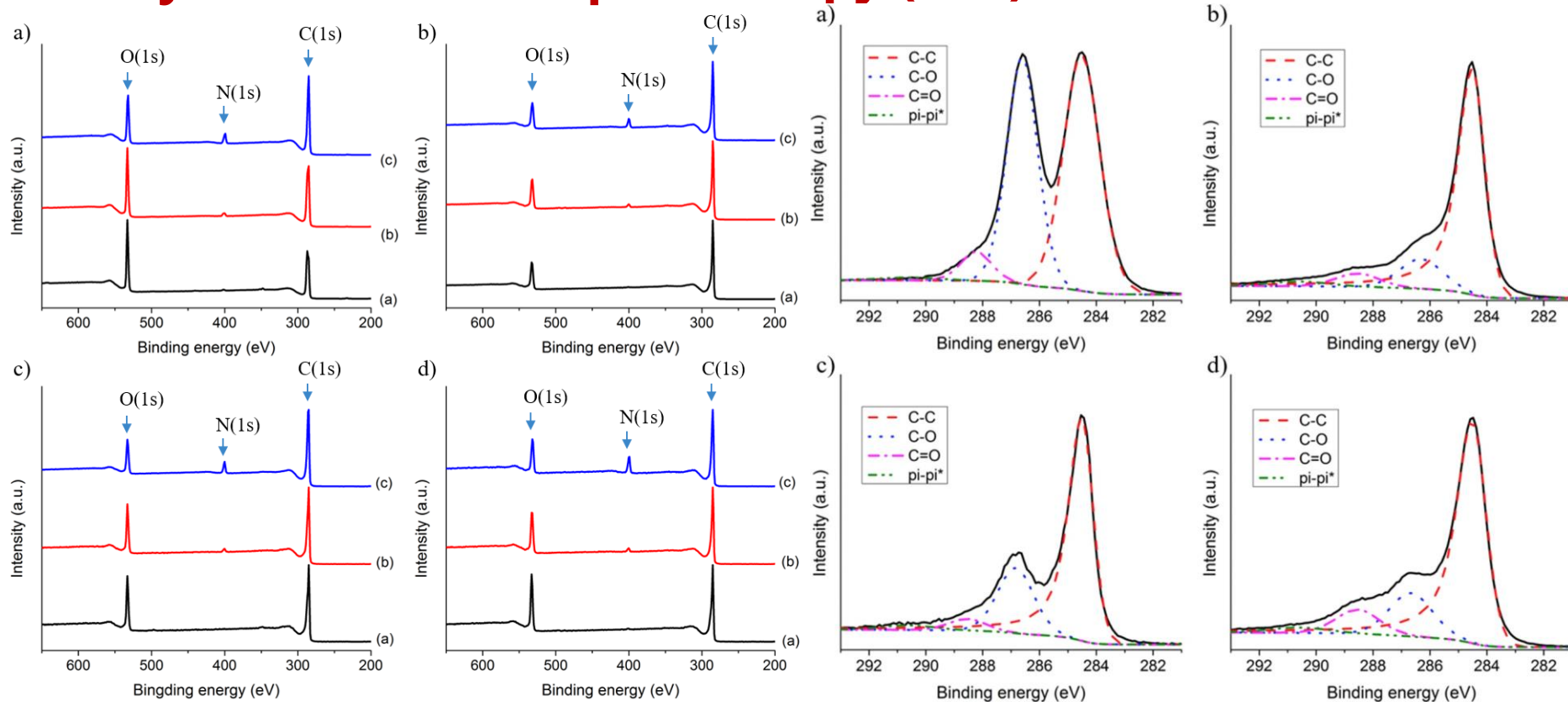
$$E_B = E_{\text{photon}} - (E_S + \phi)$$

XPS is a surface technique (10 nm dept)

XPS is applied for any kind of NM



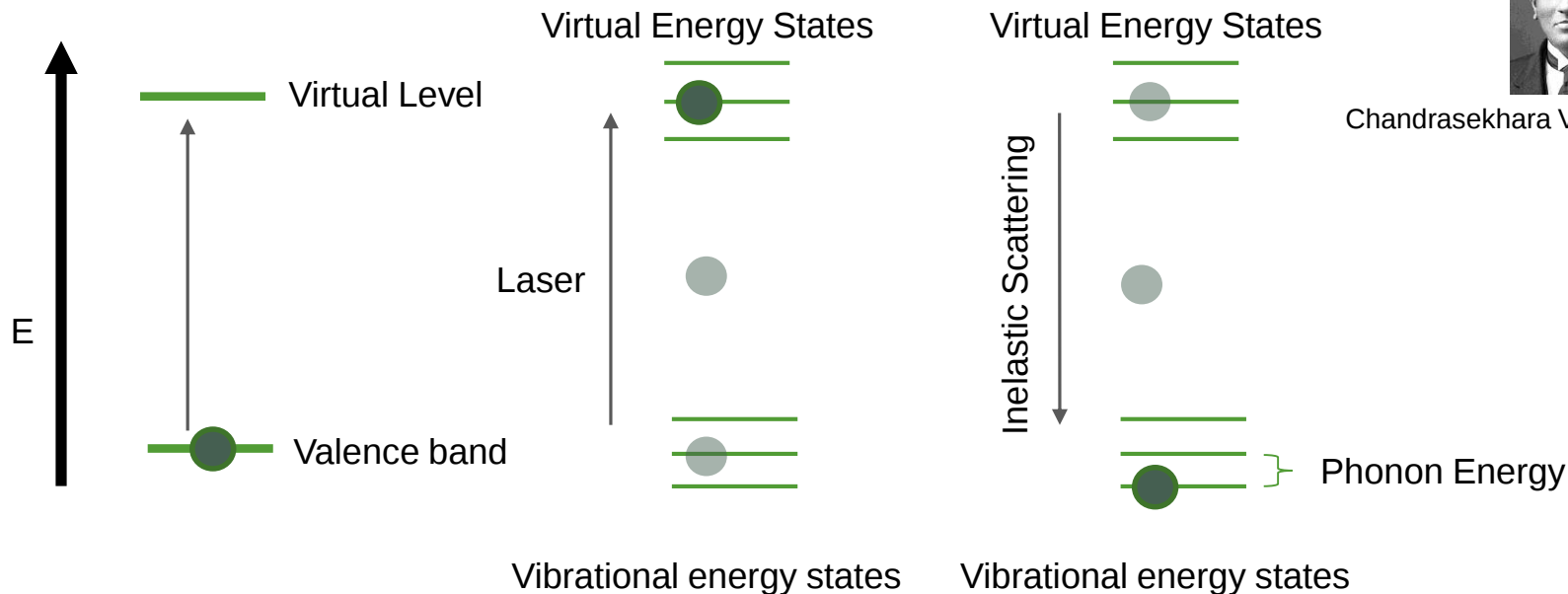
Structural Characterizations: X-ray Photoelectron Spectroscopy (XPS)



Structural Characterizations: Raman



Chandrasekhara Venkata Raman



$$E_R = E_L - E_S$$

Structural Characterizations: Raman

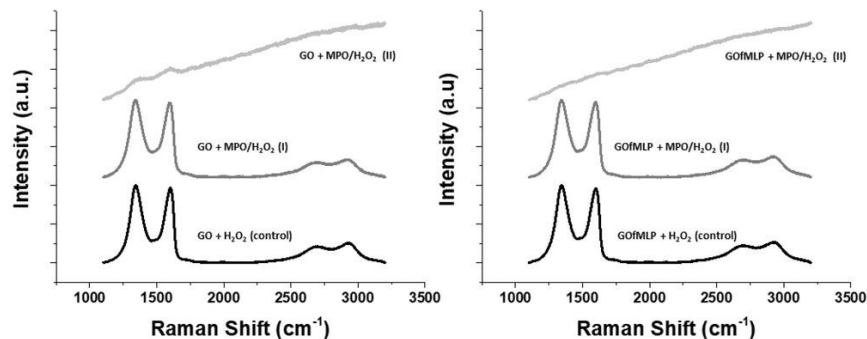
Raman Spectroscopy allows to precisely characterize the NMs

The NMs are normally in a film or placed on a solid substrate

The laser is coupled to a microscope that allows to select the area to analyze

The Raman spectra is a unique fingerprint of the NM to analyze

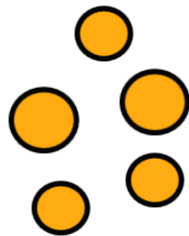
Microanalysis of large area and mapping can be also performed





Functional

Input Energy

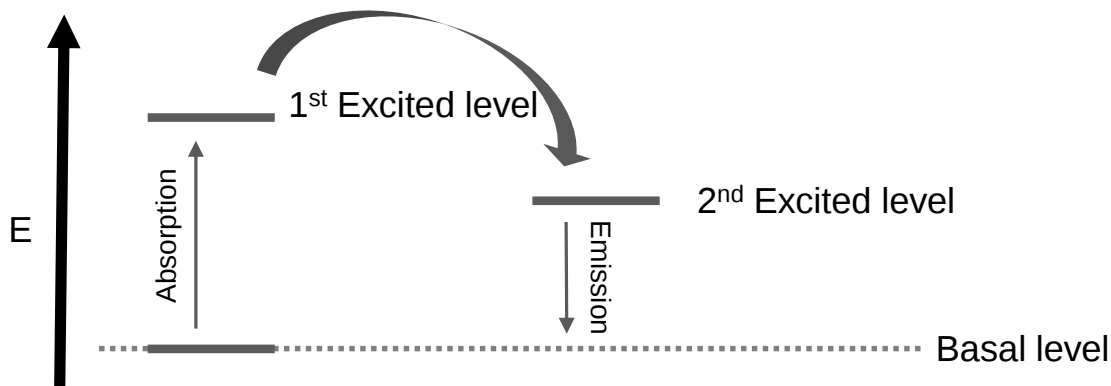


NMs

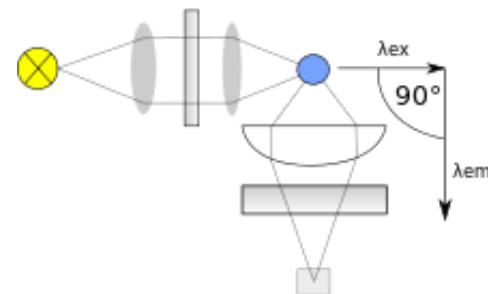
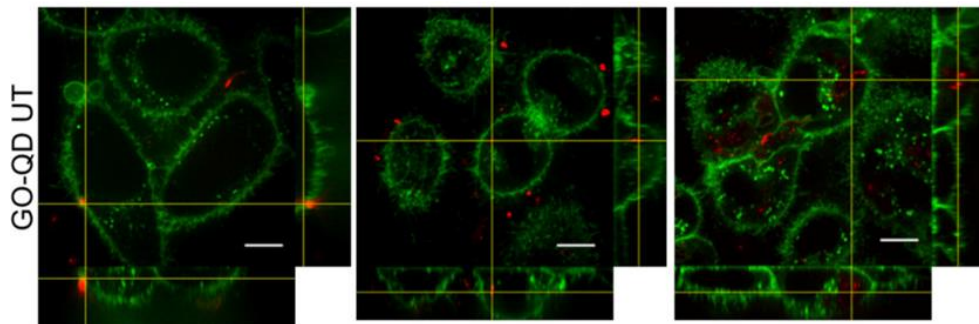
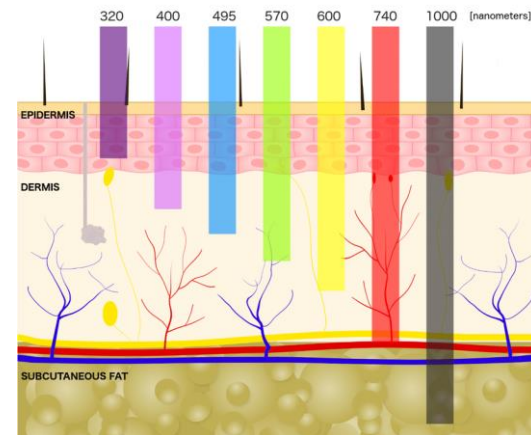
Output Energy



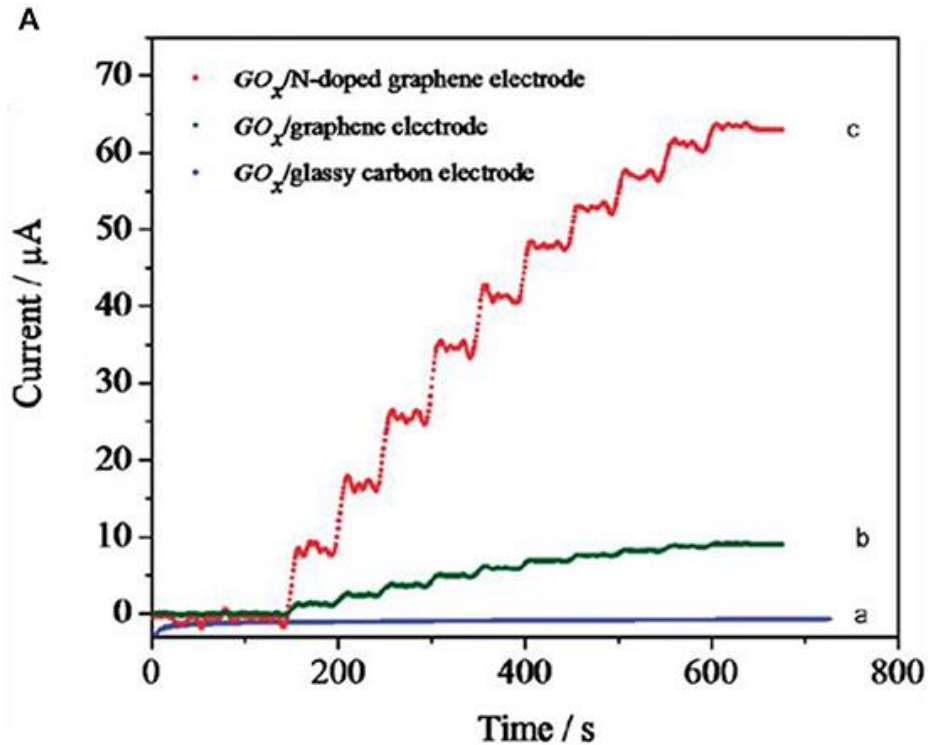
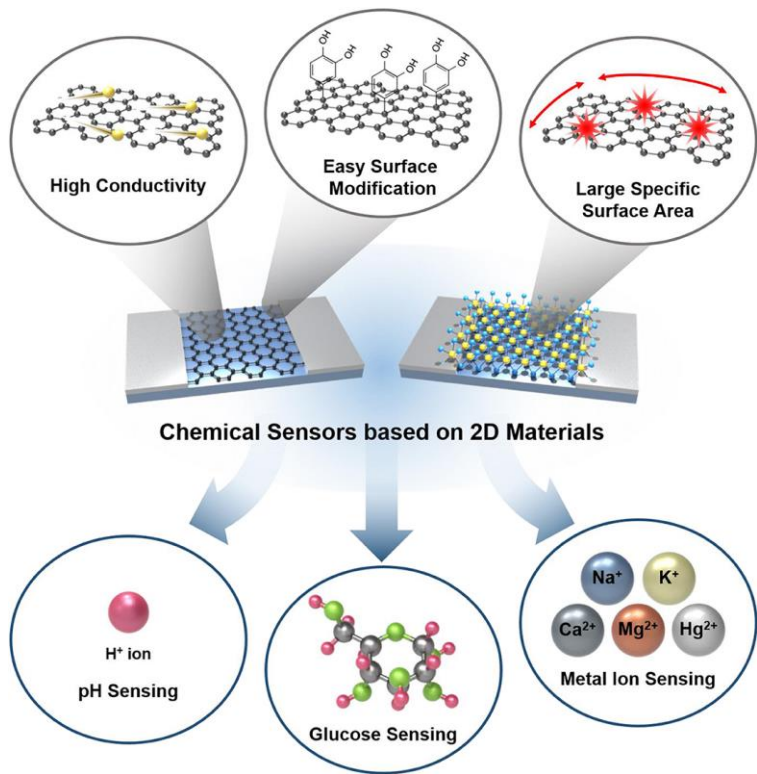
Functional Characterizations: Fluorescent bioimaging



NMs are powerful imaging platform for their high stokes shifts and quantum yield



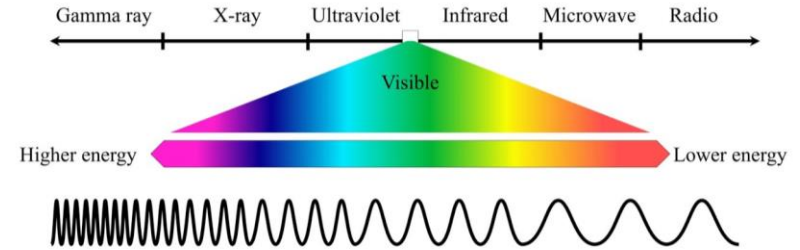
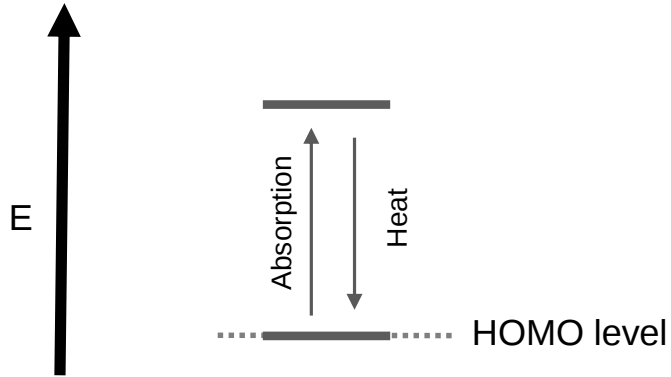
Sensing



Functional Characterizations: Photothermia

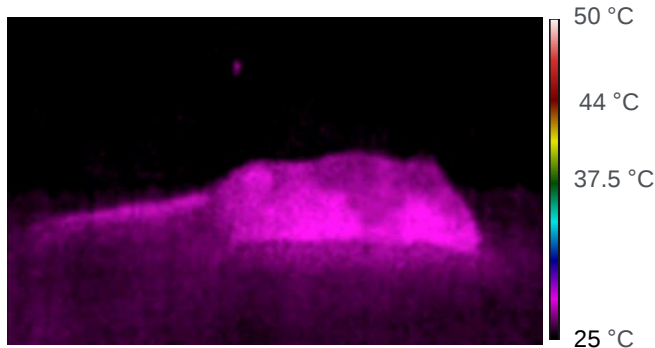


Functional Characterizations: Photothermia



Normally NIR light is used

$$\eta = \frac{hs(T_{Max} - T_{Surr}) - Q_{Dis}}{I(1 - 10^{-A_{980}})}$$



Conclusions



2D nanomaterials can be synthesized by different techniques.

We must first consider the final application of the 2D-NM.

Morphological, structural, and functional characterizations are imperative to assert the NMs.